Atterney Docket No. 081468-0307255 Chent Reference: P-1514.010-US

**PATENT** 

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

LEON MARTIN LEVASIER ARIE JEFFREY DEN BOEF

INGO DIRNSTORFER

ANDRE BERNARDUS JEUNINK STEFAN GEERTE KRULJSWIJK

HENRICUS PETRUS MARIA PELLEMANS

IRWAN DANI SETIJA and

HOITE PEITER THEODOOR TOLSMA

Application No.:

10/736,230

Confirmation No:

3133

Filed:

December 16, 2003

Group No.: Examiner

2851 TBA

For:

LITHOGRAPHIC APPARATUS WITH ALIGNMENT SUBSYSTEM, DEVICE MANUFACTURING METHOD, AND DEVICE MANUFACTURED THEREBY

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

# **SUPPLEMENTAL APPLICATION DATA SHEET** 37 C.F.R. § 1.76(c)

#### **BIBLIOGRAPHIC DATA**

## 1. Applicant information

First applicant: LEON MARTIN LEVASIER

Citizenship: The Netherlands

Residence: Stationsweg 8, NL-5321 NH Hedel, The Netherlands

Second applicant: ARIE JEFFREY DEN BOEF

Citizenship: The Netherlands

Residence: Eikenlaan 18, NL-5581 NA Waalre, The Netherlands "corrected data"

Third applicant: INGO DIRNSTORFER

Citizenship: Austria

Residence: Venbergsemolen 99, NL-5612 DX Eindhoven, The Netherlands

Fourth applicant: ANDRE BERNARDUS JEUNINK

Citizenship: The Netherlands

Residence: Burgemeester Aartslaan 39, NL-5571 TR Bergeyk, The Netherlands

Fifth applicant: STEFAN GEERTE KRUIJSWIJK

Citizenship: The Netherlands

Residence: Mathijsenlaan 2, NL-5644 JK Eindhoven, The Netherlands

Sixth applicant: HENRICUS PETRUS MARIA PELLEMANS

Citizenship: The Netherlands

Residence: De Pruikenmaker 20, NL-5506 CT Veldhoven, The Netherlands

Seventh applicant: IRWAN DANI SETIJA

Citizenship: The Netherlands

Residence: Joke Smitplein 29, NL-3581 PZ Utrecht, The Netherlands

Eighth applicant: HOITE PIETER THEODOOR TOLSMA

Citizenship: The Netherlands

Residence: Picardiehof 17, NL-5627 HL Eindhoven, The Netherlands

#### 2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

# 3. Application information

Title of Invention: LITHOGRAPHIC APPARATUS WITH ALIGNMENT SUBSYSTEM,

DEVICE MANUFACTURING METHOD, AND DEVICE

MANUFACTURED THEREBY

Docket number assigned to this application: 081468-0307255

Total number of drawing sheets: 8

Type of application: Utility

Application is to be published. Suggested drawing figure for publication: FIGURE 3

Secrecy order under § 5.2: This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

## 4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

## 5. Foreign priority information

Foreign priority is claimed for this application as follows:

Country: EUROPE

Application No.: 02080334.2 Filing Date: December 16, 2002

Country: EUROPE

Application No.: 03075423.9 Filing Date: February 14, 2003

Country: EUROPE

Application No.: 03076010.2 Filing Date: April 4, 2003

# 6. Assignee information

The assignee(s) of this application is/are:

ASML NETHERLANDS B.V.

De Run 6501, NL-5504 DR Veldhoven, THE NETHERLANDS

"Corrected Data"

Extent of interest of assignee in application: ENTIRE RIGHT, TITLE AND INTEREST.

Date: May 24, 2004

PILLSBURY WINTHROP LLP

P.O. Box 10500 McLean, VA 22102

Tel. No.: (703) 905-2085

Customer No.: 00909

Signature of Practitioner

Kerry T. Hartman Reg. No.: 41818